INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 3, 2026

IGI Report Number	LG823677008
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MIXED CUT
Measurements	10.39 X 7.05 X 4.57 MM

GRADING RESULTS

Carat Weight	3.30 CARATS
Color Grade	F
Clarity Grade	VVS 2

ADDITIONAL GRADING INFORMATION

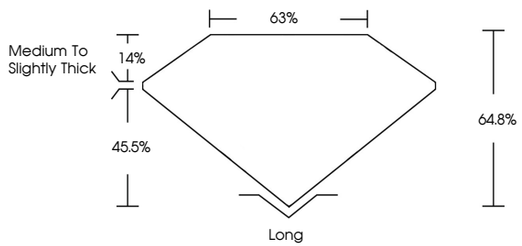
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG823677008

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG823677008

Report verification at igi.org

PROPORTIONS



Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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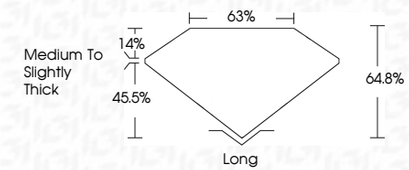

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IGI

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IGI Report No LG823677008
CUT CORNERED RECT. MIXED CUT
10.39 X 7.05 X 4.57 MM

Carat Weight	3.30 CARATS
Color Grade	F
Clarity Grade	VVS 2
Depth	64.8%
Table	63%
Girdle	Medium To Slightly Thick
Culet	Long
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG823677008

Comments:
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Type IIa